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2814-  
HFC/SS  
XA-9590  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Masao SHINOZAKI et al.

Serial No.: 10/002,009

Group Art Unit: 2814

Filed: December 5, 2001

Examiner: S. Rao

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING  
A SEMICONDUCTOR DEVICE

\* \* \*

PETITION FOR EXTENSION OF TIME

BOX AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time now set for response be extended, retroactively, by two months. The required petition fee for a large entity is submitted herewith. If any further extension of time is required to avoid abandonment of this application, such extension is hereby requested. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 that may be required by this paper to Deposit Account No. 50-1165.

08/05/2003 EFLORES 00000085 10002009

Respectfully submitted,

01 FC:1252

410.00 OP

MWS:sjk

By: Nelson H. Shapiro  
Nelson H. Shapiro  
Reg. No. 17,095

Miles & Stockbridge P.C.  
1751 Pinnacle Drive  
Suite 500  
McLean, Virginia 22102-3833  
(703) 903-9000

August 4, 2003

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